


Day : Wednesday

Date: 6/15/2005

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 **PALM INTRANET****Inventor Name Search Result**

Your Search was:

Last Name = ZHENG

First Name = LU

Application#	Patent#	Status	Date Filed	Title	Inventor Name 8
<a href="#">60040944</a>	Not Issued	159	03/17/1997	ACCESSORY APPARATUS AND METHODS	ZHENG, LU
<a href="#">60040943</a>	Not Issued	159	03/17/1997	INTELLIGENT PNEUMATIC FLOW-CONTROL VALVE AND RELATED METHODS	ZHENG, LU
<a href="#">60031666</a>	Not Issued	159	11/21/1996	BARIATRIC TREATMENT SYSTEM AND RELATED METHODS	ZHENG, LU
<a href="#">60031408</a>	Not Issued	159	11/18/1996	BARIATRIC TREATMENT SYSTEM AND RELATED METHODS	ZHENG, LU
<a href="#">60004816</a>	Not Issued	159	10/05/1995	ANGIOGENESIS USING HEPATOCYTE GROWTH FACTOR	ZHENG, LU P.
<a href="#">10200824</a>	<a href="#">6847244</a>	150	07/22/2002	VARIABLE DUTY CYCLE CLOCK GENERATION CIRCUITS AND METHODS AND SYSTEMS USING THE SAME	ZHENG, LUO

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				GROWTH TO TARGET DIAMETER GROWTH	
<u>09370349</u>	Not Issued	161	08/06/1999	OPEN-LOOP METHOD AND SYSTEM FOR CONTROLLING GROWTH OF SEMICONDUCTOR CRYSTAL	KIMBEL, STEVEN L.
<u>09287916</u>	6241818	150	04/07/1999	METHOD AND SYSTEM OF CONTROLLING TAPER GROWTH IN A SEMICONDUCTOR CRYSTAL GROWTH PROCESS	KIMBEL, STEVEN L.
<u>09053164</u>	5968263	250	04/01/1998	OPEN-LOOP METHOD AND SYSTEM FOR CONTROLLING GROWTH OF SEMICONDUCTOR CRYSTAL	KIMBEL, STEVEN L.
<u>08725861</u>	5766341	150	10/04/1996	A METHOD FOR ROTATING A CRUCIBLE OF A CRYSTAL PULLING MACHINE	KIMBEL, STEVEN L.
<u>08694157</u>	5779791	150	08/08/1996	PROCESS FOR CONTROLLING THERMAL HISTORY OF CZOCHELSKI-GROWN SILICON	KIMBEL, STEVEN L.
<u>08488924</u>	5593498	150	06/09/1995	APPARATUS FOR ROTATING A CRUCIBLE OF A CRYSTAL PULLING MACHINE	KIMBEL, STEVEN L.

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<b>Search Another: Inventor</b>	<b>Last Name</b>	<b>First Name</b>	
	<input type="text" value="Kimbel"/>	<input type="text" value="Steven"/>	<input type="button" value="Search"/>

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PALM INTRANET

**Inventor Name Search Result**

Your Search was:

Last Name = KIMBEL

First Name = STEVEN

Application#	Patent#	Status	Date Filed	Title	Inventor Name 23
<u>60577722</u>	Not Issued	159	06/07/2004	METHOD AND APPARATUS FOR GROWING SILICON CRYSTAL BY CONTROLLING THE MELT SOLID INTERFACE SHAPE AS A FUNCTION OF AXIAL LENGTH	KIMBEL, STEVEN L.
<u>60425546</u>	Not Issued	159	11/12/2002	PROCESS FOR PREPARING SINGLE CRYSTAL SILICON USING CRUCIBLE ROTATION TO CONTROL TEMPERATURE GRADIENT	KIMBEL, STEVEN L.
<u>60362379</u>	Not Issued	159	03/07/2002	METHOD AND APPARATUS FOR SLICING SEMICONDUCTOR WAFERS	KIMBEL, STEVEN L.
<u>60301767</u>	Not Issued	159	06/28/2001	PROCESS FOR PREPARING DEFECT FREE SILICON BY CONTROLLING THE AVERAGE AXIAL TEMPERATURE GRADIENT	KIMBEL, STEVEN L.
<u>60264415</u>	Not Issued	159	01/26/2001	LOW DEFECT DENSITY SILICON SUBSTANTIALLY FREE OF OXIDATION INDUCED STACKING FAULTS	KIMBEL, STEVEN L.
<u>60125456</u>	Not Issued	159	03/22/1999	METHOD AND SYSTEM FOR CONTROLLING DIAMETER OF A SILICON CRYSTAL IN A LOCKED SEED LIFT GROWTH PROCESS	KIMBEL, STEVEN L.
<u>11005987</u>	Not Issued	020	12/07/2004	LOW DEFECT DENSITY SILICON HAVING A VACANCY-DOMINATED CORE SUBSTANTIALLY FREE OF OXIDATION INDUCED	KIMBEL, STEVEN L.

				STACKING FAULTS	
<u>10699038</u>	Not Issued	041	10/31/2003	PROCESS FOR PREPARING SINGLE CRYSTAL SILICON USING CRUCIBLE ROTATION TO CONTROL TEMPERATURE GRADIENT	KIMBEL, STEVEN L.
<u>10623967</u>	Not Issued	071	07/21/2003	METHOD TO MONITOR AND CONTROL THE CRYSTAL COOLING OR QUENCHING RATE BY MEASURING CRYSTAL SURFACE TEMPERATURE	KIMBEL, STEVEN L.
<u>10430483</u>	Not Issued	041	05/06/2003	PROCESS FOR SUPPRESSING THE NUCLEATION AND/OR GROWTH OF INTERSTITIAL TYPE DEFECTS BY CONTROLLING THE COOLING RATE THROUGH NUCLEATION	KIMBEL, STEVEN L.
<u>10377271</u>	Not Issued	041	02/28/2003	METHOD AND APPARATUS FOR SLICING SEMICONDUCTOR WAFERS	KIMBEL, STEVEN L.
<u>10054629</u>	<u>6846539</u>	150	01/22/2002	LOW DEFECT DENSITY SILICON HAVING A VACANCY-DOMINATED CORE SUBSTANTIALLY FREE OF OXIDATION INDUCED STACKING FAULTS	KIMBEL, STEVEN L.
<u>09684266</u>	<u>6482263</u>	150	10/06/2000	HEAT SHIELD ASSEMBLY FOR CRYSTAL PULLING APPARATUS	KIMBEL, STEVEN L.
<u>09661745</u>	Not Issued	161	09/14/2000	PROCESS FOR SUPPRESSING THE NUCLEATION AND/OR GROWTH OF INTERSTITIAL TYPE DEFECTS BY CONTROLLING THE COOLING RATE THROUGH NUCLEATION	KIMBEL, STEVEN L.
<u>09502340</u>	<u>6776840</u>	150	02/10/2000	METHOD OF CONTROLLING DIAMETER OF A SILICON CRYSTAL IN A LOCKED SEED LIFT GROWTH PROCESS	KIMBEL, STEVEN L.
<u>09421187</u>	<u>6203611</u>	150	10/19/1999	METHOD OF CONTROLLING GROWTH OF A SEMICONDUCTOR CRYSTAL TO AUTOMATICALLY TRANSITION FROM TAPER	KIMBEL, STEVEN L.